Pulse studies of CH₄ interaction with NiO/Al₂O₃ catalysts

C.T. Au^{a,1}, Y.H. Hu^{a,b} and H.L. Wan^b

 ^a Department of Chemistry, Hong Kong Baptist College, 224 Waterloo Road, Kowloon, Hong Kong
 ^b Department of Chemistry and State Key Laboratory for Physical Chemistry, Xiamen University, Xiamen 361005, PR China

Received 21 January 1994; accepted 18 April 1994

Pulse studies of the interaction of CH₄ and NiO/Al₂O₃ catalysts at 500°C indicate that CH₄ adsorption on reduced nickel sites is a key step for CH₄ oxidative conversion. On an oxygen-rich surface, CH₄ conversion is low and the selectivity of CO₂ is higher than that of CO. With the consumption of surface oxygen, CO selectivity increases while the CO₂ selectivity falls. The conversion of CH₄ is small at 500°C when a pulse of CH₄/O₂ (CH₄ : O₂ = 2 : 1) is introduced to the partially reduced catalyst, indicating that CH₄ and O₂ adsorption are competitive steps and the adsorption of O₂ is more favorable than CH₄ adsorption

Keywords: pulse reaction; NiO/Al₂O₃ catalysts; methane activation

1. Introduction

During the last decade or so, a considerable amount of efforts have been devoted to the conversion of methane to transportable and/or value added products [1–4]. Besides the well-known methane oxidative coupling process, partial oxidation of methane to syngas has recently been found to be promising. High selectivities to CO and H_2 with excellent methane conversion have been reported over a number of supported transition metal catalysts, particularly the Ni catalysts [4–8].

The activation of methane on Ni single-crystal surfaces and model thin films of NiO had been studied by a number of researchers, using techniques such as molecular beam [9], Auger electron spectroscopy [10,11], and theoretical calculations [12]. However, for practical supported nickel catalysts, the CH_4/O_2 to syngas reaction was investigated mainly using continuous flow microreactor systems. Data concerning activity and selectivity of the catalysts were obtained, but a very limited

¹ To whom correspondence should be addressed.

amount of information about the interaction of methane with the catalysts is made available. Moreover, Lunsford and coworkers [13] found that during the catalytic oxidation of CH₄ to syngas over Ni/Yb₂O₃ catalysts in the continuous flow reaction system and at high space velocities, the exothermic reaction gave rise to large temperature gradation, resulting in the generation of hot spots. The temperature of the hot spots would be as much as 300°C higher than the temperature measured by thermocouple. Because of this hot spot problem, data obtained by Choudhary et al. [5–7] are considered to be questionable [13]. In a pulse microreactor, the reactant gas is introduced in pulses, and because the amount of reactant introduced is small each time, hot spots are not generated and reliable data can be obtained. In this paper, we studied the activation of methane over NiO/Al₂O₃ catalysts using the pulse method. Some useful information about CH₄ activation was obtained. The mechanism of CH₄ interaction with NiO is discussed.

2. Experimental

Catalyst preparation. The NiO/Al₂O₃ catalyst (with 10 wt% of nickel) was prepared by impregnating Al₂O₃ powder with nickel nitrate (BDH, A.R. grade) solution. The paste generated was dried at 110°C and annealed at 400°C for decomposition. After being pressed and crushed, the material was sieved to a grain size of 20–40 mesh before being calcined at 800°C in air for 4 h.

Pulse reaction system. The reaction was carried out using a pulse microreactor. A schematic diagram of the system is shown in fig. 1. The reactor was made of stainless-steel tube with 4 mm i.d. For each study, 50 mg of NiO/Al_2O_3 catalyst



Fig. 1. Schematic diagram of the pulse microreactor system: (1) helium, (2) methane, (3) oxygen, (4) hydrogen, (5) four-way valve, (6) gas mixing tube, (7) six-way valves, (8) sampling tubes, (9) thermocouple, (10) reactor, (11) temperature programmed oven, (12) 5A zeolite column, (13) Porapak Q, (14) thermal conductivity detector.

was used. The pulse volumes of CH_4 , O_2 , H_2 and CH_4/O_2 were 1.11, 0.44, 1.03 and 1.03 ml respectively. During the reaction, helium was used as carrier gas and its flow rate was 17 ml/min. At 500°C, in the absence of the catalyst NiO/Al₂O₃ or in the presence of the support material Al₂O₃, the blank runs showed no activity whatsoever under the reaction conditions mentioned in this paper.

3. Results and discussion

By introducing pulses of CH_4 to the catalyst bed at 500°C, we monitored the activity and selectivity of

(I) freshly prepared NiO/Al_2O_3 catalyst;

(II) NiO/Al₂O₃ catalyst partially reduced by one pulse of H₂ (1.03 ml) at 500°C;

(III) NiO/Al₂O₃ catalyst treated with CH_4/O_2 ($CH_4: O_2 = 2: 1$, pressure = 1 atm, flow rate = 54 ml/g s) for 10 min at 700°C.

In case I, the CH_4 conversion during the first pulse of CH_4 was extremely small, implying that the surface of the catalyst was not active (fig. 2a). However,



Fig. 2. The relationship between (a) CH₄ conversion and (b) selectivity of CO or CO₂ and ordinal number of CH₄ pulsing over freshly prepared NiO/Al₂O₃ catalyst at 500°C.

during the second pulse, CH₄ conversion was obviously higher with CO₂ as the main product (figs. 2a and 2b). CH₄ conversion was highest (ca. 19%) at the third pulse of CH₄. Further exposure of the catalyst to pulses of CH₄ resulted in the decline of CH₄ conversion and CO₂ selectivity, with the CO selectivity being observed to increase. After the sixth pulse, the conversion of CH₄ was 3.5% and it declined to 1% at the twelfth pulse. CO₂ selectivity was 100% initially and, after the fourth pulse, dropped to about 23% while the CO selectivity respectively increased from 0 to 77%.

In case II, the catalyst was partially reduced by one time of H_2 pulsing at 500°C. The conversion of CH_4 was highest (ca. 26%) at the first pulse of CH_4 . Further exposure of the catalyst to pulses of CH_4 resulted in the decline of CH_4 conversion and CO_2 selectivity with the CO selectivity being observed to increase (fig. 3).

In case III, the catalyst was treated with CH_4/O_2 . CH_4 conversion was ca. 25% at the first and second pulse and then declined gradually afterwards (fig. 4a). CO_2 selectivity was higher than CO initially and as the number of pulses increased, CO_2 selectivity dropped while CO selectivity rose (fig. 4b).



Fig. 3. The relationship between (a) CH₄ conversion and (b) selectivity of CO or CO₂ and ordinal number of CH₄ pulsing over NiO/Al₂O₃ catalyst reduced by one time of pulsing H₂ at 500°C.



Fig. 4. The relationship between (a) CH₄ conversion and (b) selectivity of CO or CO₂ and ordinal number of CH₄ pulsing at 500°C over NiO/Al₂O₃ catalyst after pretreatment in CH₄ + O₂ (CH₄ : O₂ = 2 : 1) at 700°C.

Fig. 5 shows that, when a mixture of CH₄ and O₂ (CH₄/O₂ = 2/1) was pulsed to a NiO/Al₂O₃ catalyst which had been treated with CH₄/O₂ (CH₄/O₂ = 2/1, pressure = 1 atm, flow rate = 54 ml/g s) for 10 min at 700°C, the conversion of CH₄ at 500°C stayed at around 1% and the CO₂ selectivity was 100% at every pulse of CH₄/O₂.

A freshly prepared NiO/Al₂O₃ catalyst would have a surface composed of oxide. Initial CH₄ pulsing at 500°C showed little activation but CH₄ conversion definitely increased in the second and third pulsing (fig. 2). This may be because initial interaction between methane and the surface is that between CH₄(g) and NiO(s). The process is possible but slow at 500°C. Since no CO and H₂ were detected at the first pulse of methane, initial Ni sites were mainly generated by total oxidation of methane. Once reduced sites are generated, CH₄ adsorption and dissociation become feasible, resulting in higher CH₄ conversion. This shows that reduced nickel sites have higher ability for CH₄ activation than nickel oxide sites. CH₄ conversion increased as the reduced nickel sites increased with the ordinal number of CH₄ pulses. However, as the surface is further reduced, it is deprived of



Fig. 5. The relationship between (a) CH₄ conversion and (b) selectivity of CO₂ and ordinal number of CH₄/O₂(2/1) pulsing at 500°C over the NiO/Al₂O₃ catalyst after pretreatment in CH₄ + O₂ (CH₄ : O₂ = 2 : 1) at 700°C.

oxygen and CH₄ conversion reached a maximum and declined afterward. After the initial pulse of methane, CO and H₂ were generated, implying reduced Ni sites could be further generated by total as well as partial oxidation of methane. When NiO/Al₂O₃ was first partially reduced by one pulse of H₂, the conversion of CH₄ was at its highest during the first pulse of CH₄ (fig. 3). This is because enough amount of reduced nickel sites was already generated by the pulse of hydrogen before the first pulse of CH₄ was introduced. It has been shown that methane adsorbs dissociatively on Ni(100) [10,11], Ni(111) [9,10,12] and Ni(110) surfaces [10]. Campbell et al. showed that the reaction probability of methane on NiO films was significantly lower than that observed on the clean Ni(100) surface [11]. These results are consistent with our data over the NiO/Al₂O₃ catalyst.

After the NiO/Al₂O₃ catalyst was treated with CH₄/O₂ at 700°C, CH₄ conversion at 500°C reached 25% at the first pulse of CH₄ (fig. 4), indicating that some reduced nickel sites were generated in the CH₄/O₂ to syngas process at 700°C. This is consistent with the XPS and XRPD results obtained by Lunsford and coworkers [14].

At 500°C, CH_4/O_2 mixture reacted poorly with the reduced catalyst (fig. 5), indicating that the adsorptions of O_2 and CH_4 on the reduced sites were competitive processes. As O_2 chemisorption occurs more readily than CH_4 chemisorption, the surface is reoxidized, rendering the chemisorption of CH_4 unfavorable and resulting in poor CH_4 conversion.

In all cases, CO_2 formation was more favorable than CO initially and as the surface was deprived of oxygen, CO_2 selectivity decreased and CO selectivity increased. Based on the above observations, we propose the following mechanism for the interaction between CH₄ and NiO/Al₂O₃ at 500°C:

$$2NiO + \frac{1}{2}CH_4(g) \to 2Ni + \frac{1}{2}CO_2(g) + H_2O(g)$$
(1)

$$Ni + CH_4(g) \rightarrow CH_x(s) + (4 - x)H(s)$$
⁽²⁾

$$CH_x(s) \rightarrow C(s) + xH(s)$$
 (3)

$$H(s) + H(s) \rightarrow H_2(g) + 2Ni$$
⁽⁴⁾

$$C(s) + NiO \rightarrow Ni + CO(s)$$
⁽⁵⁾

$$CO(s) + NiO \rightarrow CO_2(s) + Ni$$
 (6)

$$CO(s) \rightarrow Ni + CO(g)$$
 (7)

$$CO_2(s) \rightarrow Ni + CO_2(g)$$
 (8)

$$2H(s) + NiO \rightarrow H_2O(g) + Ni.$$
(9)

Comparing with step 2, step 1 is very difficult. After the initial generation of Ni sites in step 1, the activation of CH_4 occurs mainly according to step 2 and the generation of CO, CO_2 and H_2 follows the steps similar to those proposed by Hickman et al. [8] over Pt and Rh monoliths.

Acknowledgement

The project was kindly supported by the Hong Kong Baptist College and the Research Grants Council, UPGC.

References

- Y. Amenomyia, V. Birrs, M. Goledzinowski, J. Gluszka and A.R. Sanger, Catal. Rev.-Sci. Eng. 32 (1990) 163.
- [2] J.R. Anderson, Appl. Catal. 47 (1989) 177.

- [3] J.H. Lunsford, Catal. Today 6 (1990) 235.
- [4] P.D.F. Vernon, M.L. Green, A.K. Cheetham and A.T. Ashcroft, Catal. Lett. 6 (1990) 181.
- [5] V.R. Choudhary, A.M. Rajput and B. Prabhakar, Catal. Lett. 15 (1992) 363.
- [6] V.R. Choudhary, A.M. Rajput and B. Prabhakar, J. Catal. 139 (1993) 326.
- [7] V.R. Choudhary, A.M. Rajput and V.H. Rane, Catal. Lett. 16 (1992) 269.
- [8] D.A. Hickman, E.A. Haupfear and L.D. Schmidt, Catal. Lett. 17 (1993) 223;
 D.A. Hickman and L.D. Schmidt, J. Catal. 138 (1992) 267.
- [9] M.B. Lee, Y. Yang and S.T. Ceyer, J. Chem. Phys. 87 (1987) 2724.
- [10] T.P. Beebe, D.W. Goodman, B.D. Kay and J.T. Yates, J. Chem. Phys. 87 (1987) 2305.
- [11] R.A. Campbell, J. Szanyi, P. Lenz and D.W. Goodman, Catal. Lett. 17 (1993) 39.
- [12] J. Schule, P. Siegbahn and U. Wahlgren, J. Chem. Phys. 89 (1988) 6983.
- [13] D. Dissanayake, M.P. Rosynek and J.H. Lunsford, J. Phys. Chem. 97 (1993) 3644.
- [14] D. Dissanayake, M.P. Rosynek, K.C.C. Kharas and J.H. Lunsford, J. Catal. 132 (1991) 117.